10191/4116

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Franz LAERMER et al.

International Application No.

PCT/DE03/01437

International Filing Date

May 6, 2003

U.S. Serial No.

10/524,610

For

LAYER SYSTEM HAVING A SILICON

LAYER AND A PASSIVATION LAYER.

METHOD FOR CREATING A

PASSIVATION LAYER ON A SILICON

LAYER AND ITS USE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Attention: PCT - Missing Parts

RESPONSE TO MISSING REQUIREMENTS UNDER 35 U.S.C. 371

SIR:

In response to the Notification of Missing Requirements Under 35 U.S.C. 371 in the United States Designated/Elected Office (DO/EO/US) (mailed June 30, 2005), Applicants submit herewith a fully executed Declaration, in order to complete the filing requirements for the U.S. national phase of the above-identified PCT application. The application filed in the Patent Office is the application which the inventors executed by signing the Declaration and Power of Attorney. A copy of the Notification of Missing Requirements is enclosed.

The Office is authorized to charge the \$130.00 fee to cover the surcharge for late filing of the Declaration.

The Office is also hereby authorized to charge Deposit Account No. 11-0600 with any additional fees required by this paper or credit any overpayment. An additional copy of this letter is enclosed for this purpose.

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Respectfully submitted, KENYON & KENYON

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United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE UNITED STATES DEPARIMENT OF COMMU United States Patent and Trademark Office Address COMMISSIONER FOR PATENTS P.O. Dox 1450 Alexandria, Virgina 22313-1450 www.usplu.gov

U.S. APPLICATION NUMBER NO.	FIRST NAMED APPLICANT	ATTY. DOCKET NO.
10/504 610	T	10101/4116

Franz Laermer 10/524,610

10191/4116

PRIORITY DATE

INTERNATIONAL APPLICATION NO.

PCT/DE03/01437

LA. FILING DATE

05/06/2003

CONFIRMATION NO. 9981 371 FORMALITIES LETTER

OC000000016410612

26646 **KENYON & KENYON** ONE BROADWAY NEW YORK, NY 10004

Date Mailed: 06/30/2005

NOTIFICATION OF MISSING REQUIREMENTS UNDER 35 U.S.C. 371 IN THE UNITED STATES DESIGNATED/ELECTED OFFICE (DO/EO/US)

The following items have been submitted by the applicant or the IB to the United States Patent and Trademark Office as a Designated / Elected Office (37 CFR 1.495).

- Copy of the International Application filed on 02/16/2005
- Copy of the International Search Report filed on 02/16/2005
- Preliminary Amendments filed on 02/16/2005
- Information Disclosure Statements filed on 02/16/2005
- Oath or Declaration filed on 02/16/2005
- Request for Immediate Examination filed on 02/16/2005
- U.S. Basic National Fees filed on 02/16/2005
- Priority Documents filed on 02/16/2005

The following items MUST be furnished within the period set forth below in order to complete the requirements for acceptance under 35 U.S.C. 371:

- Oath or declaration of the inventors, in compliance with 37 CFR 1.497(a) and (b), identifying the application by the International application number and international filing date. The current oath or declaration does not comply with 37 CFR 1.497(a) and (b) in that it:
 - is not executed in accordance with either 37 CFR 1.66 or 37 CFR 1.68.

ALL OF THE ITEMS SET FORTH ABOVE MUST BE SUBMITTED WITHIN TWO (2) MONTHS FROM THE DATE OF THIS NOTICE OR BY 32 MONTHS FROM THE PRIORITY DATE FOR THE APPLICATION. WHICHEVER IS LATER, FAILURE TO PROPERLY RESPOND WILL RESULT IN ABANDONMENT.

The time period set above may be extended by filing a petition and fee for extension of time under the provisions of 37 CFR 1.136(a).

Applicant is reminded that any communications to the United States Patent and Trademark Office must be mailed to the address given in the heading and include the U.S. application no. shown above (37 CFR 1.5)

A copy of this notice **MUST** be returned with the response.

LAMONT M HUNTER

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PART 1 - ATTORNEY/APPLICANT COPY

U.S. APPLICATION NUMBER NO.	INTERNATIONAL APPLICATION NO.	ATTY. DOCKET NO.
10/524,610	PCT/DE03/01437	10191/4116

FORM PCT/DO/EO/905 (371 Formalities Notice)



Title: LAYER SYSTEM HAVING A SILICON LAYER AND A PASSIVATION LAYER, METHOD HAVING A SILICON LAYER AND A LAYER ON A SILICON LAYER AND ITS USE Matter: 4116

Client: 10191 Application No: 10/524610 (P49342 USW 0 31666)

